

# Solid Sample Analysis of non-metallic elements (I,P,S) via Electrothermal Vaporisation by Optical Emission Spectroscopy with Inductively Coupled Plasma

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## ETV: Principle of operation

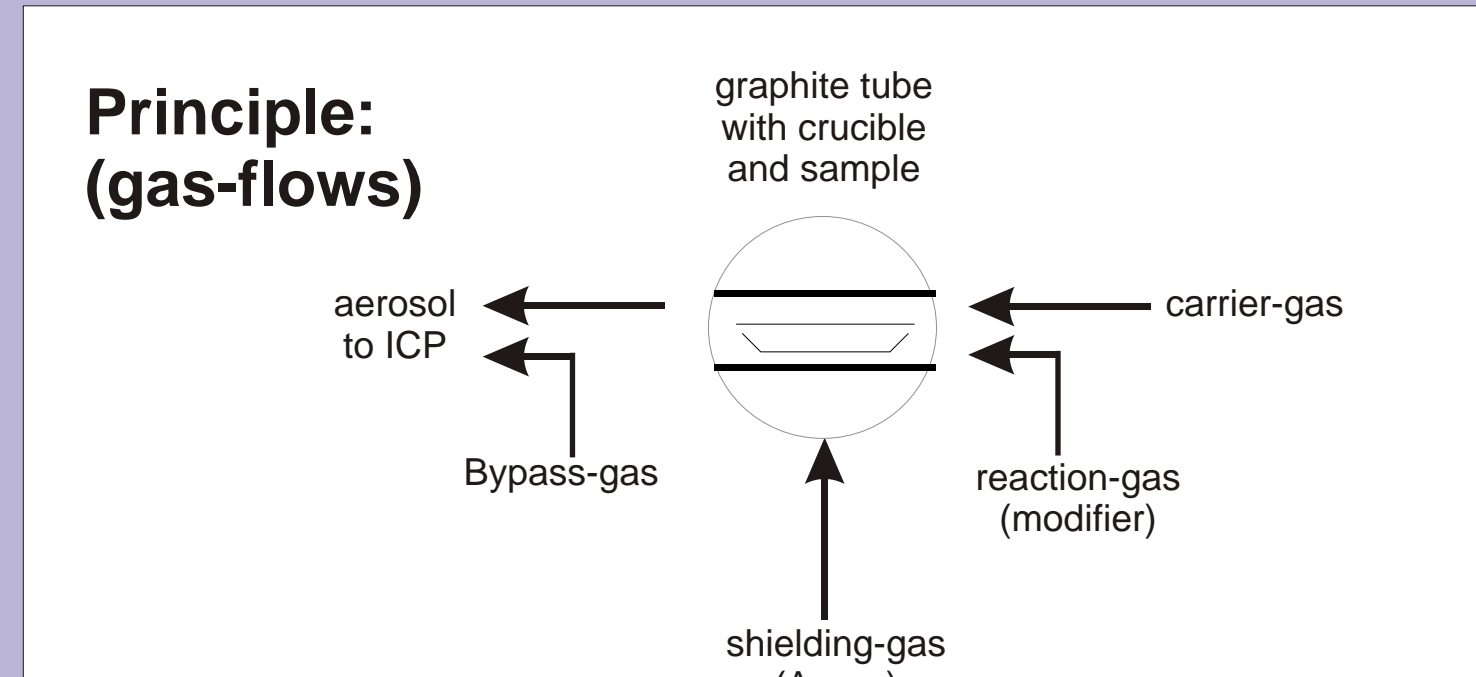
Temperature-controlled evaporation of sample in a graphite crucible positioned in a graphite-tube furnace with Argon atmosphere (up to 3000°C). Electronic controlled addition of a small amount of reaction-gas (modifier).

Transport of the aerosol to the ICP-plasma by optimised gas guide with high transport-efficiency. Integrated microprocessor-control with graphic LCD-display, electronic gas-flow-control and -mixing, synchronisation by electronic interface. This allows the application of individual time-temperature-programs.

Automatic boat-temperature control by integrated online pyrometer from 10°C up to 3000°C.

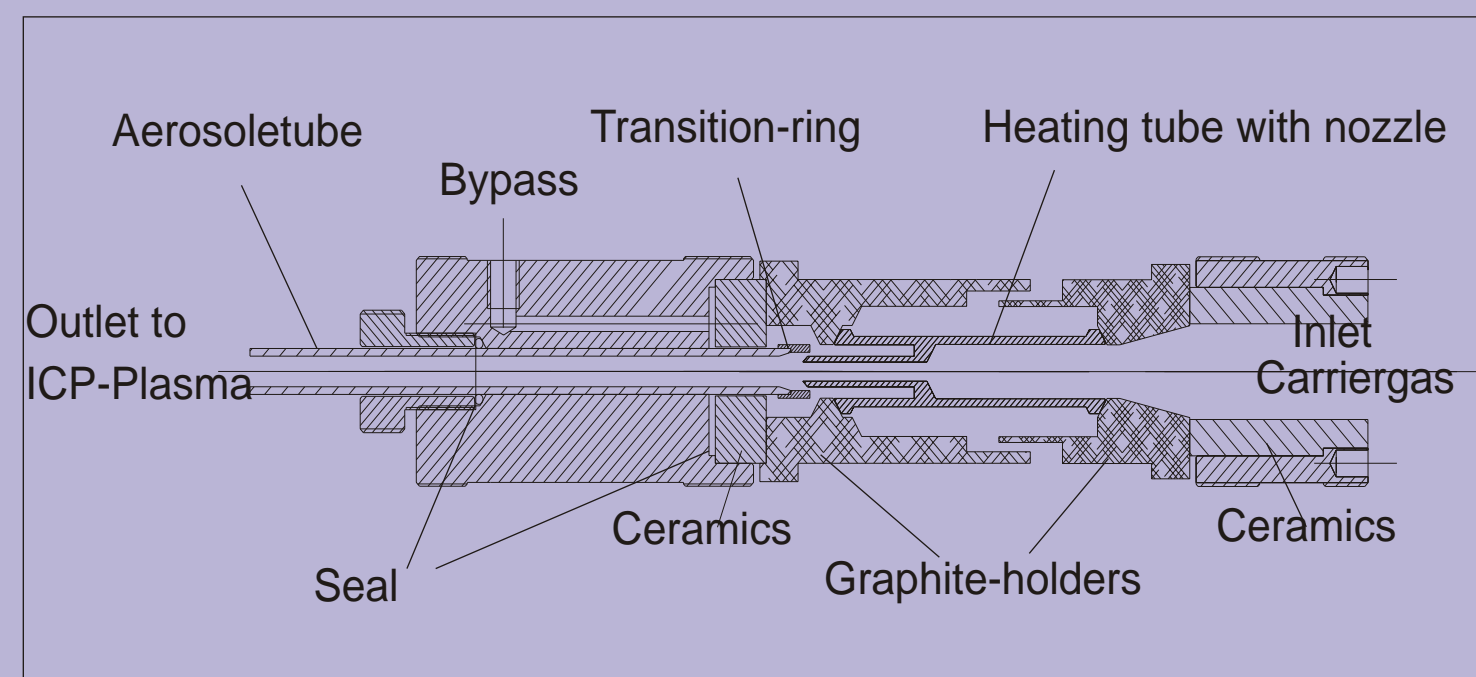
Automated sample-handling by autosampler with up to 50 positions, microbalance.

## Schematic of the gas-flow of ETV

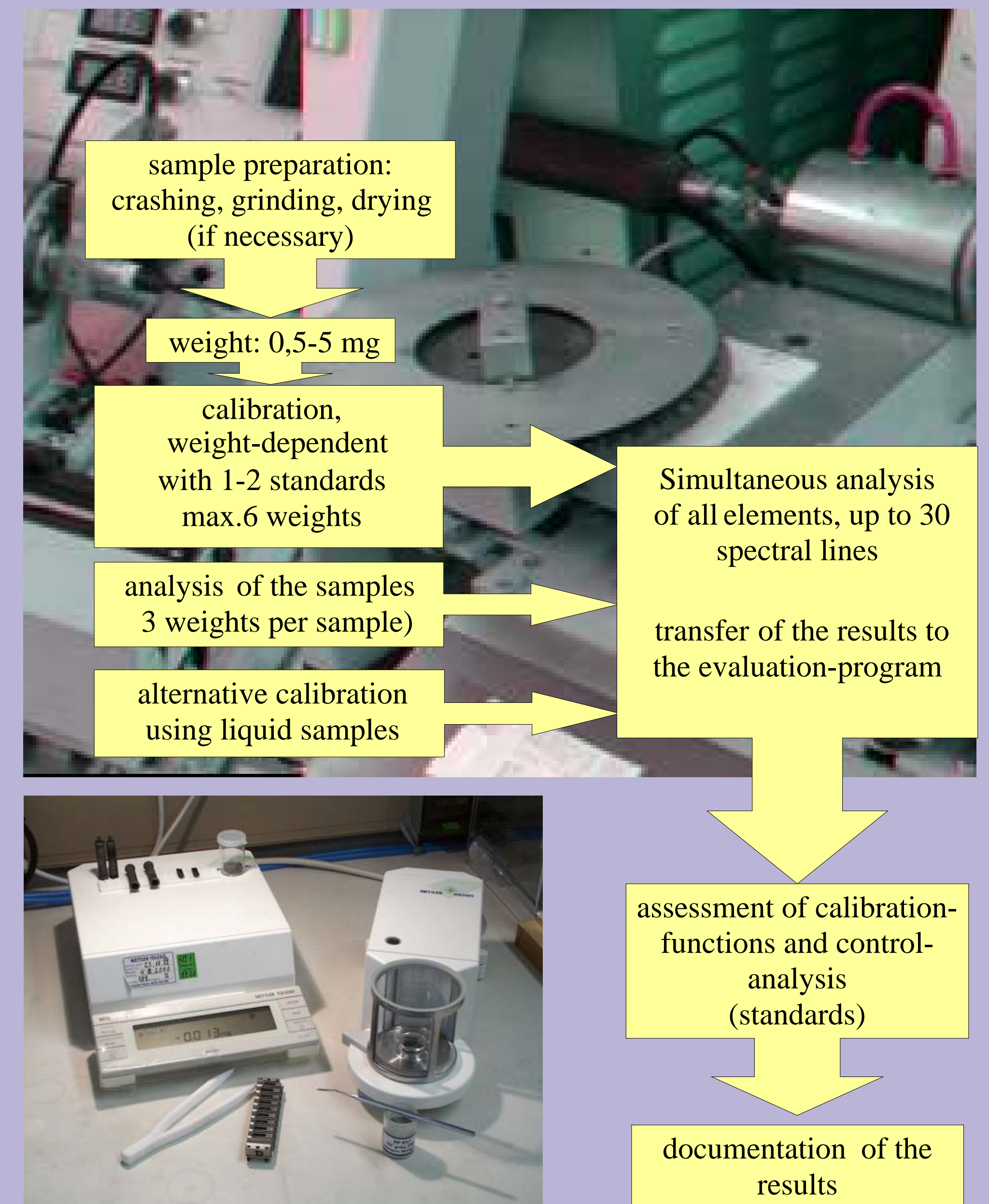


## Graphite-furnace, new design

stable up to 3000°C, chemical inert materials, easy handling and maintenance, minimised seals, reduced number of working parts



## ETV-analysis: example for a typical procedure



## Examples of application

The results of analysed element-concentrations were calculated basing on the shown calibration functions. The points on these common calibration functions (dried liquid standards and solid sample material) show an excellent correlation and thereby prove the correctness and the convincing features of this method.

### The investigated materials were:

- Graphite (home standards) ©
- Ceramic Materials (BN, TiO<sub>2</sub>, TiB<sub>2</sub>)
- NIST SRM 1515 Apple Leaves (AL)
- Milk Powder (MP)

### Example:

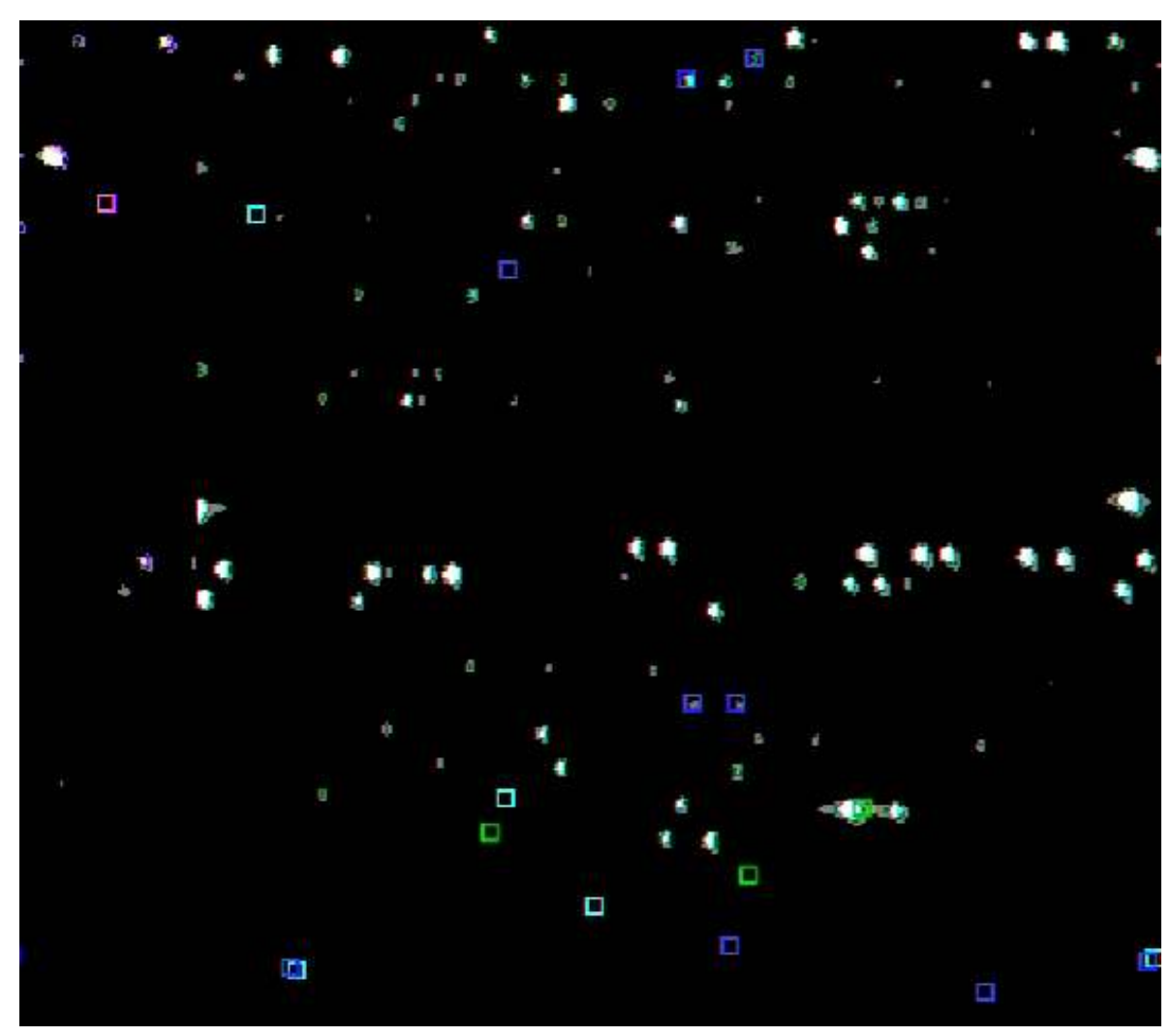
Gas flow and furnace-program for Iodine

Weight: 1 – 5 mg

Furnace-program: step 1: 30s 300°C  
step 2: 2s 300°C to 1600°C  
step 3: 28s 1600°C  
step 4: cooling 50s

Gases: Argon: carrier 120 ml/min  
by-pass 380 ml/min  
Freon: 2.3 ml/min

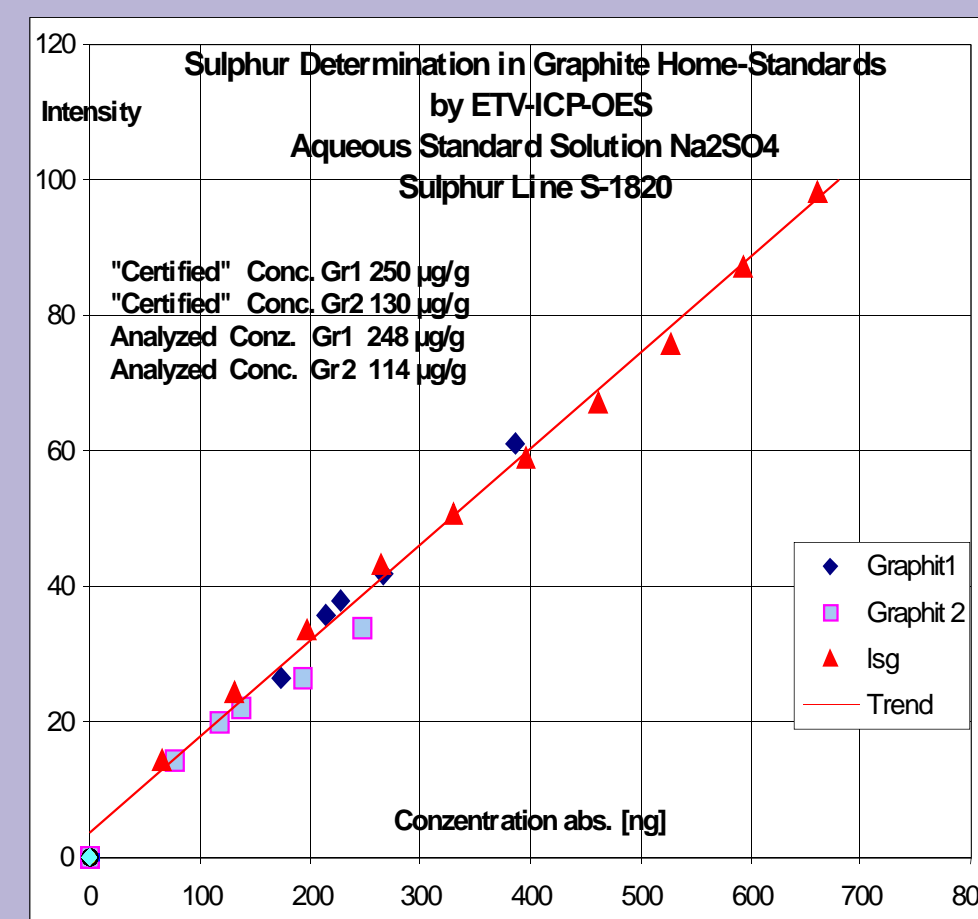
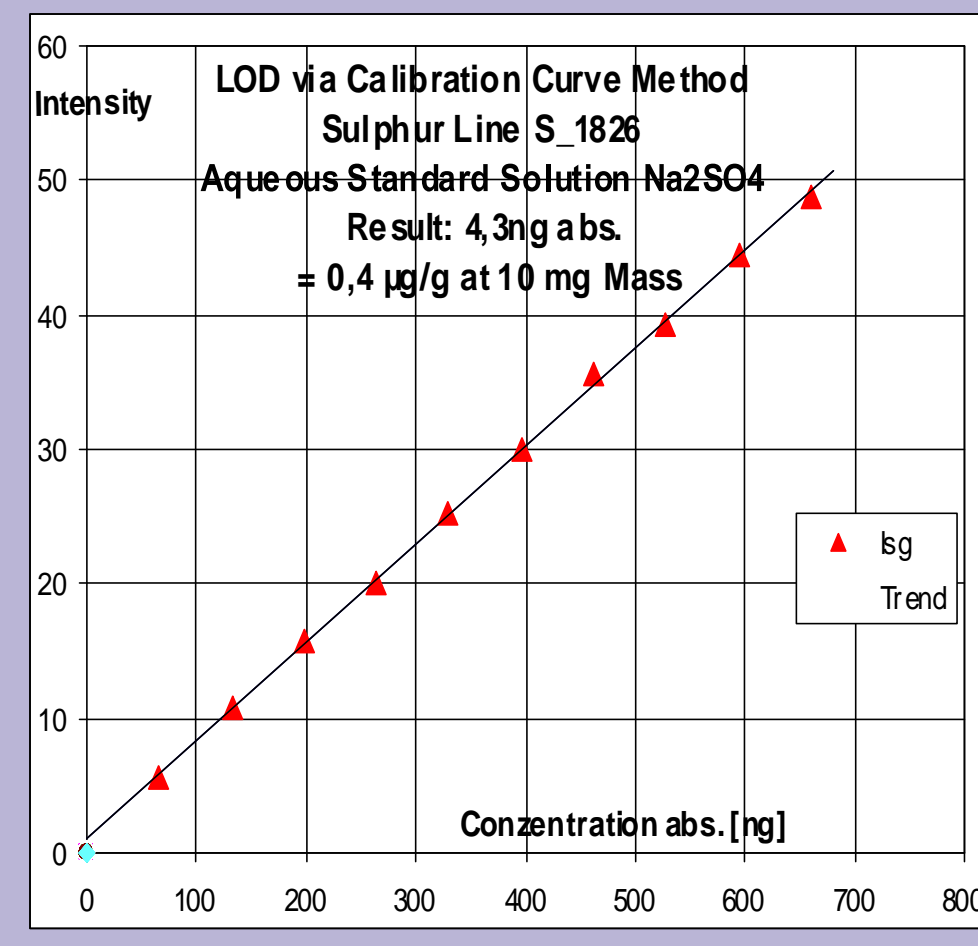
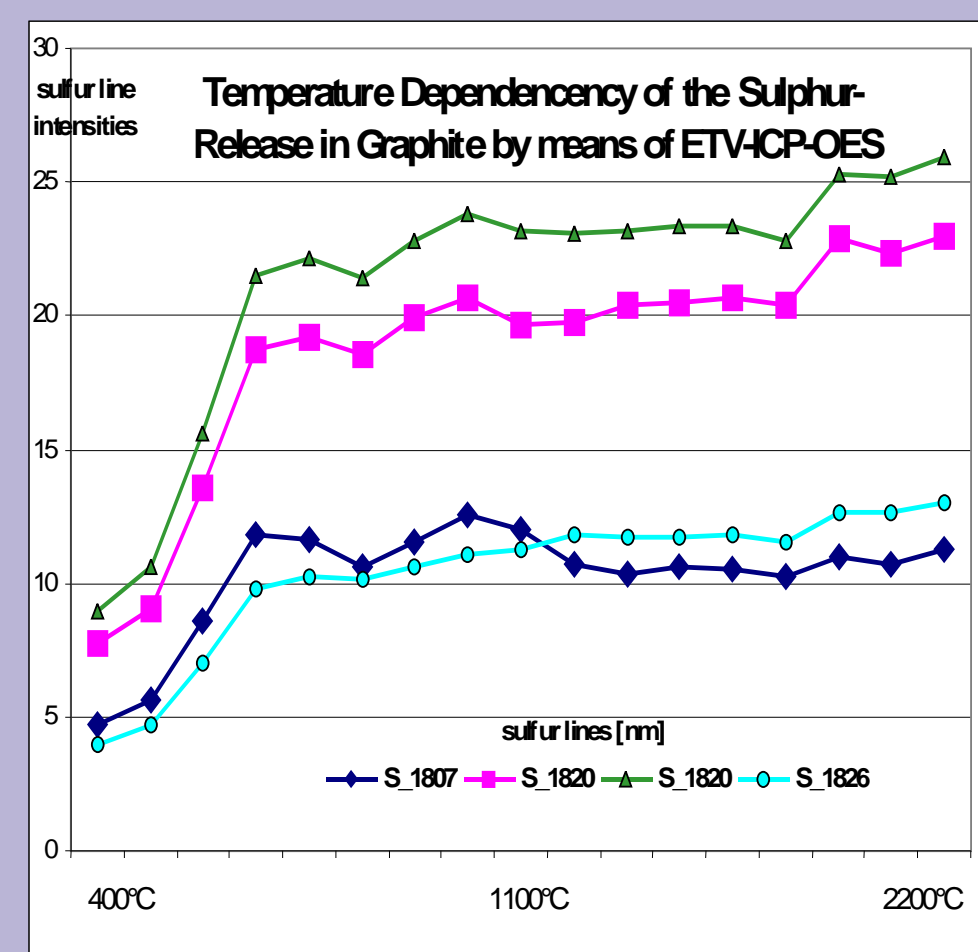
### Echelle-picture of the chip area of interest (I,S,P) between the 189th and 156th order



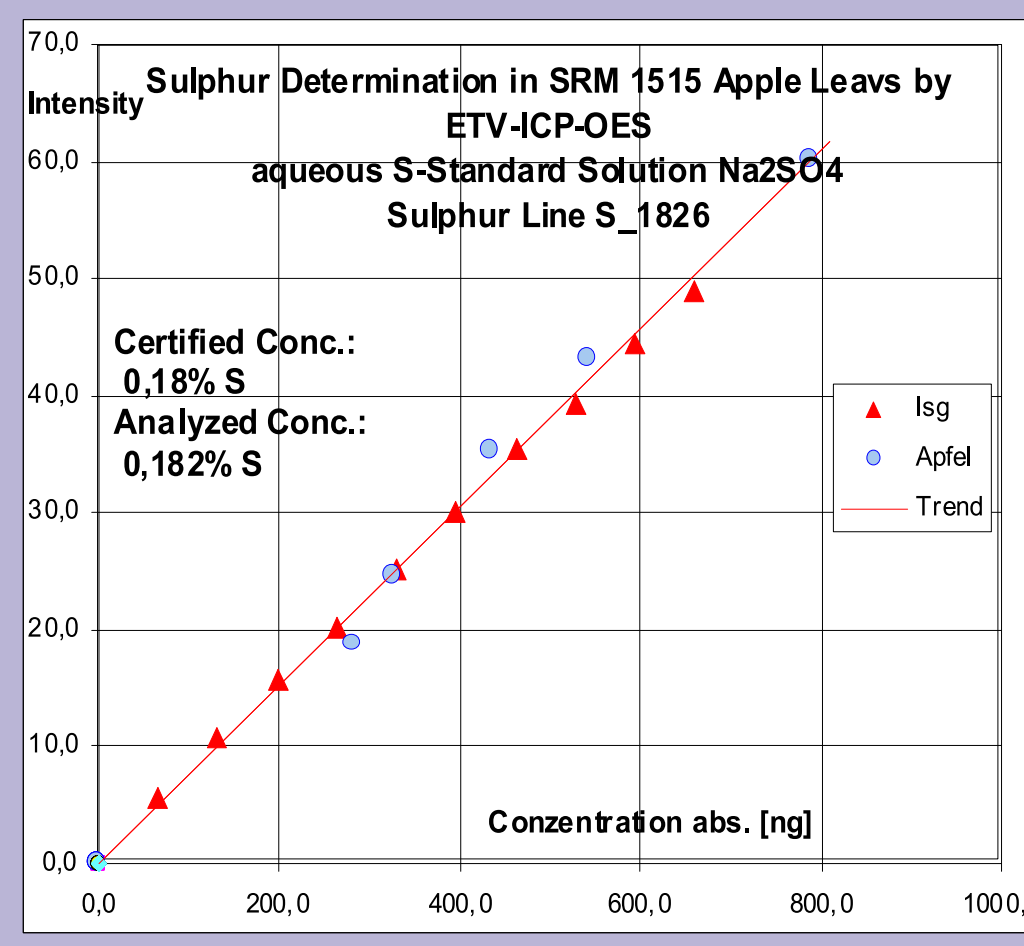
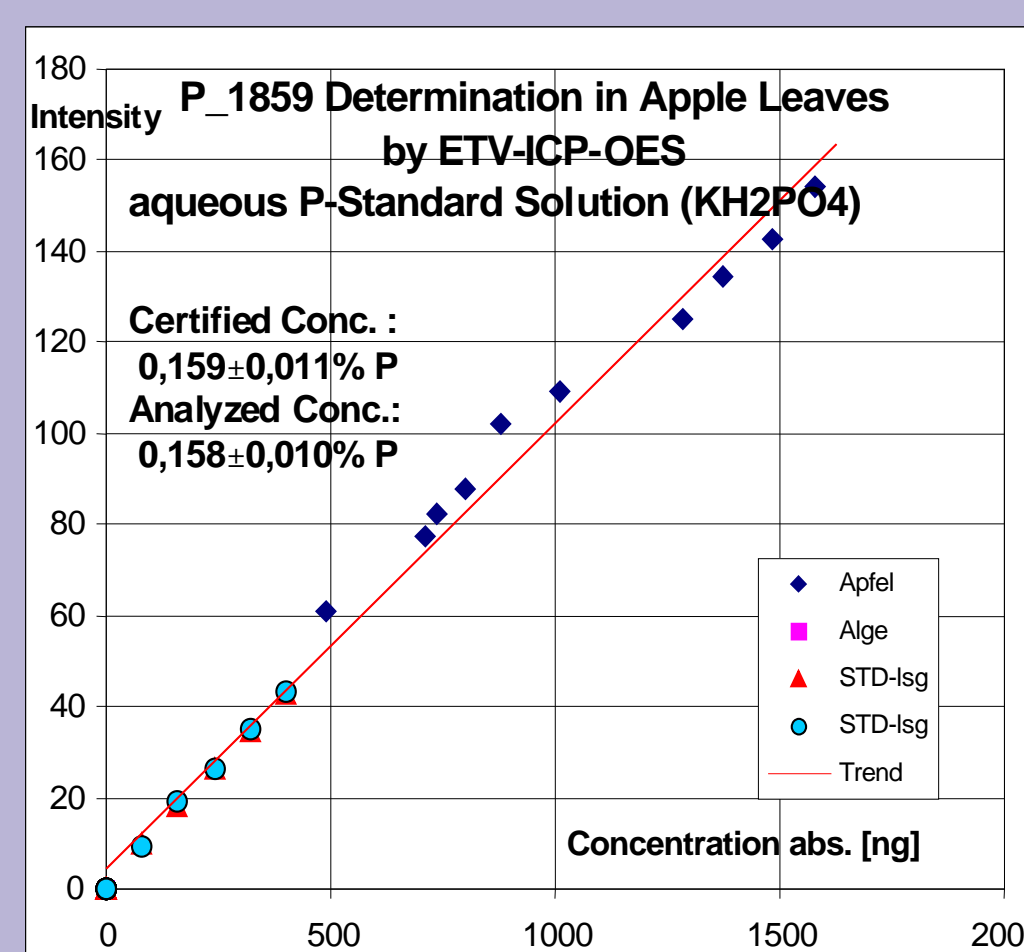
### Analytical Lines of I,P,S

Element	Line	Wavelength [nm]
Iodine	178.276	188
Iodine	179.903	186
Iodine	183.038	182
Iodine	206.190	162
Phosphorus	177.499	189
Phosphorus	178.287	188
Phosphorus	178.768	187
Phosphorus	185.891	180
Phosphorus	185.943	180
Phosphorus	203.349	165
Phosphorus	213.618	157
Phosphorus	214.914	156
Sulphur	180.731	185
Sulphur	182.034	183
Sulphur	182.624	183

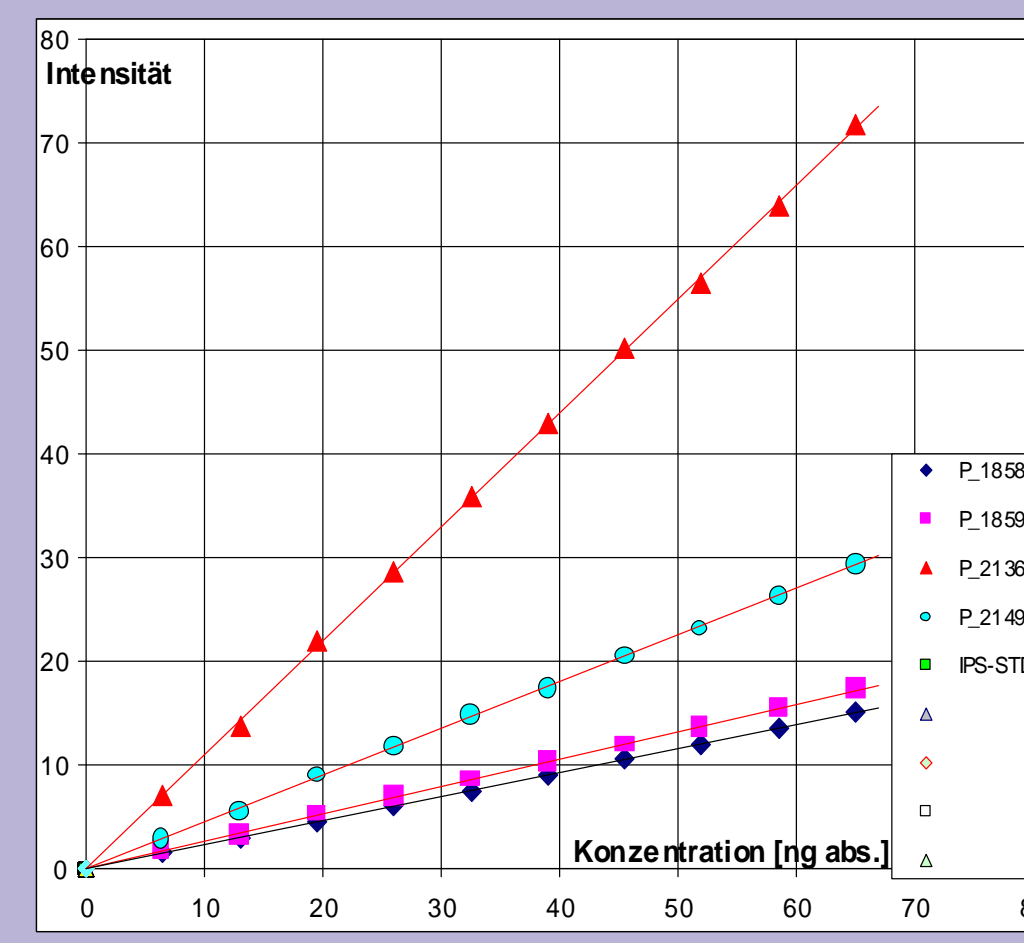
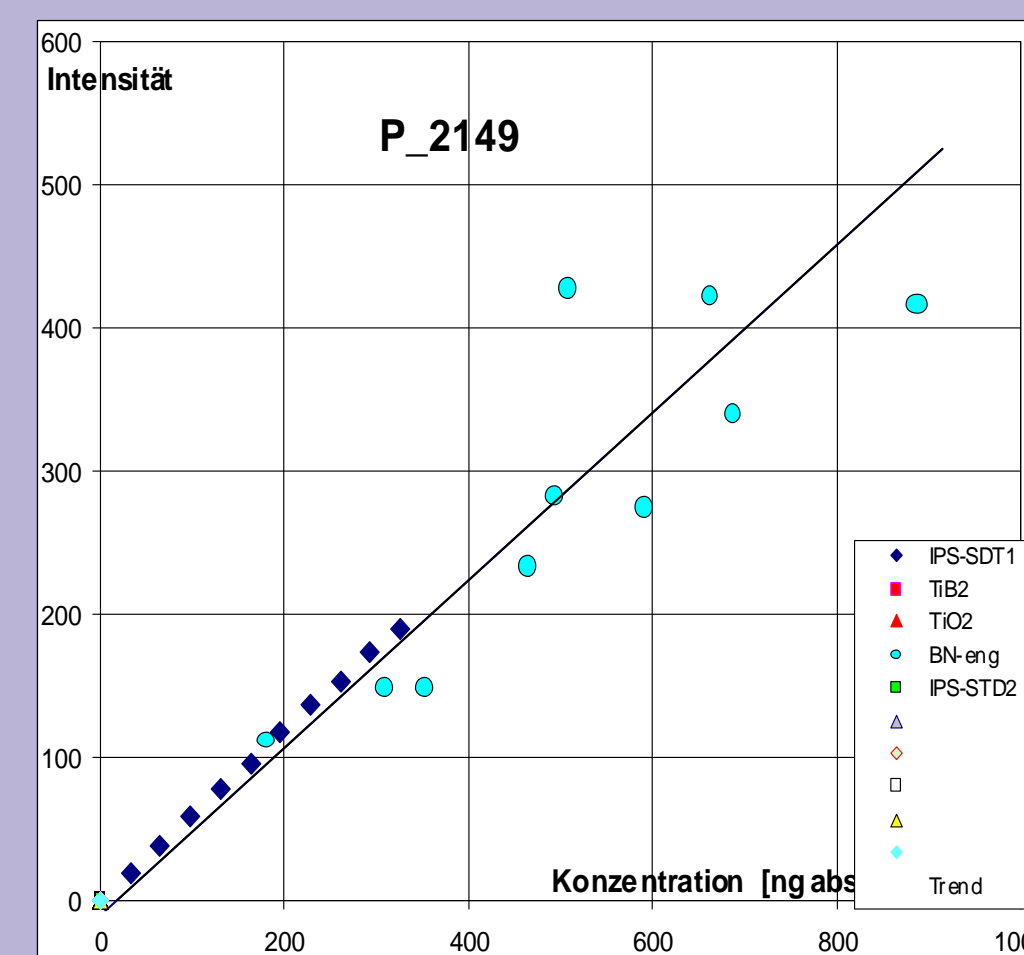
## S in Graphite



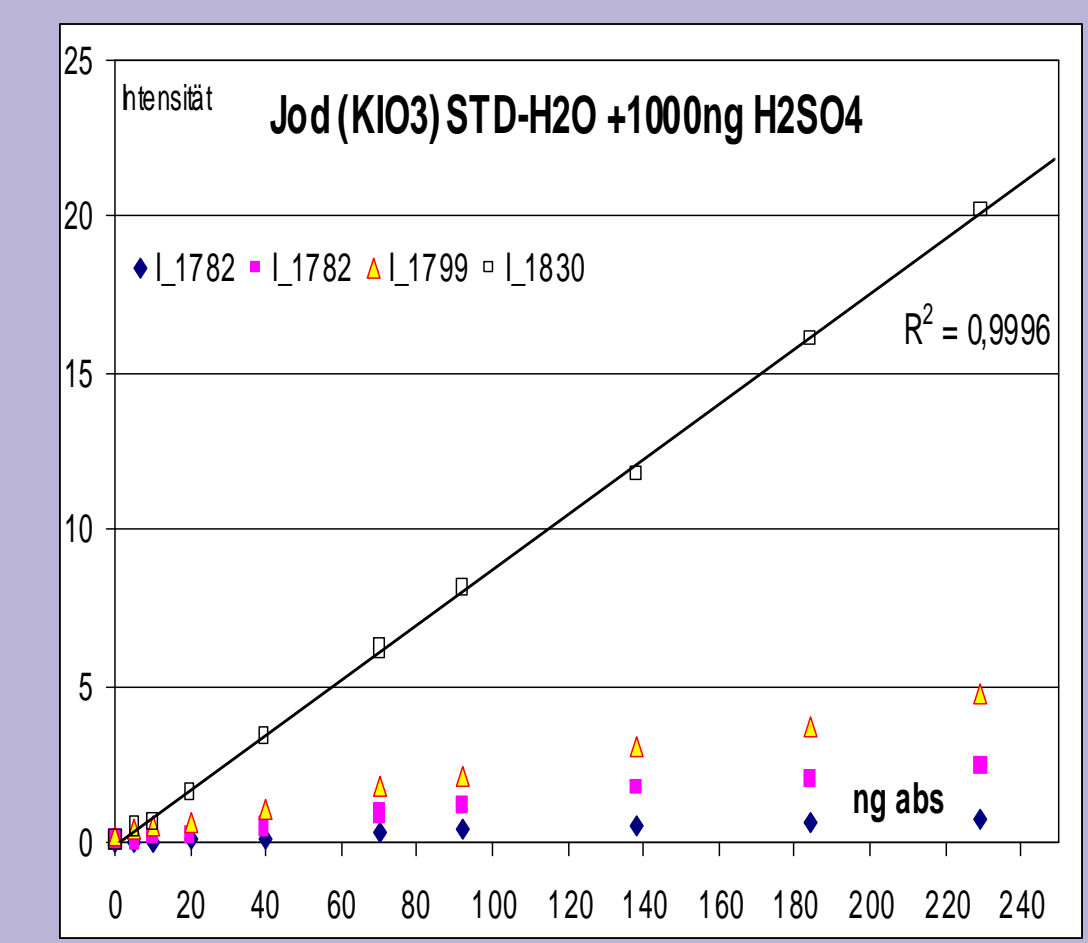
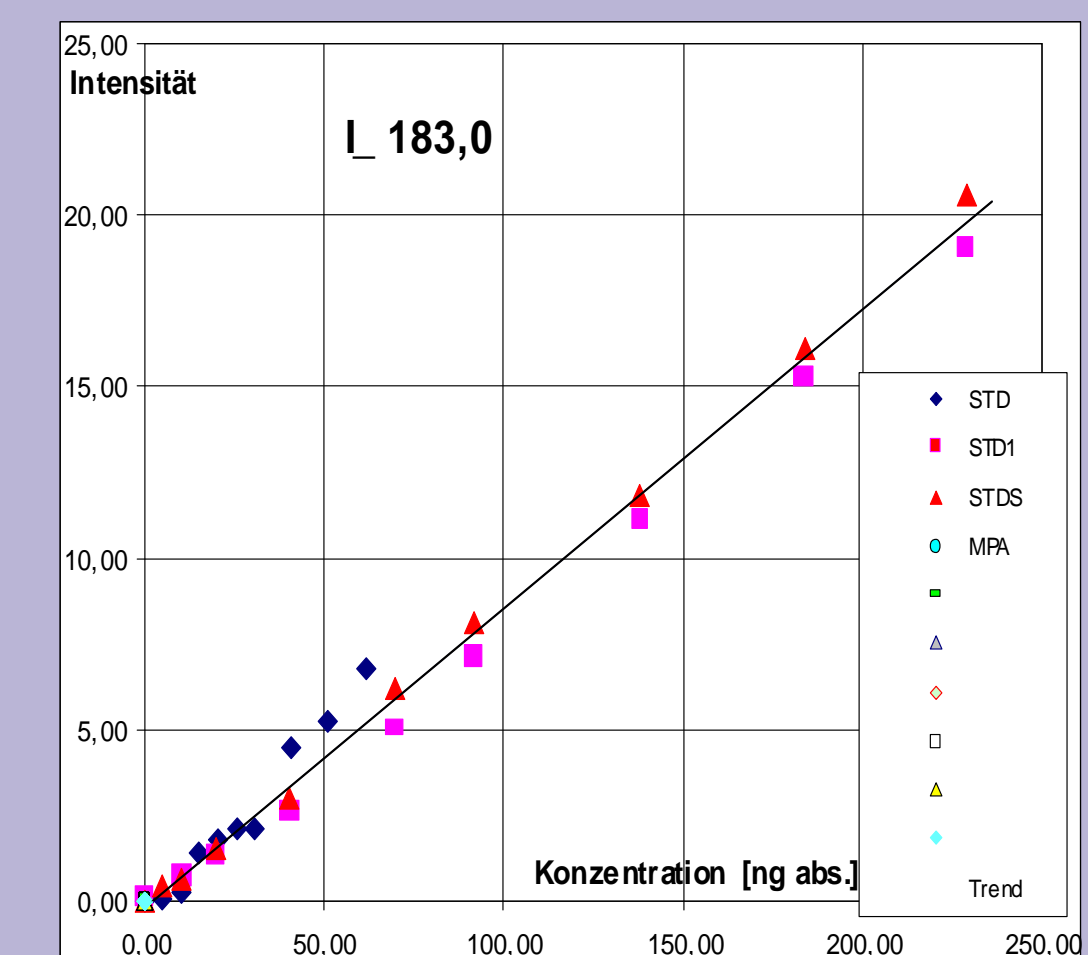
## S, P in Apple Leaves



## P in Ceramic Materials



## I in Ashed Milk Powder



Tab. Experimental setup for ETV-ICP-OES:	
ICP-Spectrometer	IRIS-AP Thermo Jarrell Ash Echelle-polychromator, Argon rinsed Echelle grating 60 grooves/mm
Spectral data	Focal distance: 381mm Resolution: at 200 nm width of one pixel 0,0035 nm Spektral range: 175-1050nm
Signal detection	CID-camera
ICP	Active surface of CID chip: 14,3x14,3mm (512 x 512 pixel) axially plasma; RF generator: 1150 W at 27,12 Mhz
ETV-unit	ETV 4000 P.Perzl; Spectral Systems; Power supply: max power 400 A; end-on stream system; Furnace control: inside temperature controlled

## Results

Element	Line	LOD [ng abs.]	Material	Element	concentration	
					expectet	found
I	183.0	3 – 5	TiB <sub>2</sub>	P	20 ± 5	9.5 ± 2
	179.9	7 – 11		P	510 ± 35	620 ± 40
P	185.891	0.7	BN	P	600 ± 50	550 ± 80
	185.943	0.8	Apple leaves	P	1590 ± 110	1580 ± 100
	213.618	0.5		S	1800 ± 100	1820 ± 50
	214.914	0.7	Graphite Gr1	S	250 ± 15	248 ± 10
S	182.0	1 - 2	Graphite Gr2	S	130 ± 15	114 ± 10
	182.6	4 - 5		I	0.8-1.5	1.12 ± 0.25
			MP (standard addition)	I	0.8-1.05	0.95 ± 0.25

## Conclusions:

As well known, modern ETV-ICP configurations are an excellent and cost-effective tool for easy, fast and precise direct solid sample multi-element analysis in a wide area of applications. The field of applications ranges from anorganic materials like ceramics and geological samples up to environmental samples and biological materials like plant materials or animal tissues and foods. The presented results demonstrate the easy and uncomplicated possibilities of calibration via liquid standard solutions compared with reference materials or home standards. The calibration with a single material standard only or even with dried fluid standard solution offers the possibility to analyse elements or materials even if no reference materials are available.

The limits of detection for the shown elements are 0.5 – 10 µg abs. and so, dependent to the weight less than 1 ppm. The reproducibility is in all cases better than 10 % rel.

The ETV-equipment is further more rationalised by an autosampler with up to 50 crucibles and integrated micro-balance.

On the basis of the presented statistical results the power of a modern ETV-ICP-OES device should be evident.